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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor: Toru TATSUMI et al.

Serial No.: 09/744,701

Confirmation No.: 3273

Filed: January 29, 2001

Title: **METHOD OF VAPOR PHASE GROWTH OF METAL
OXIDE DIELECTRIC FILM AND APPARATUS FOR
VAPOR PHASE GROWTH OF METAL DIELECTRIC
MATERIAL**

Examiner: H. Jey Tsai

Group Art Unit: 2812

Attorney Docket No.: NECW 18.281 (100806-17349)

November 29, 2005

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Office Action dated June 29, 2005, please amend the subject application as follows: